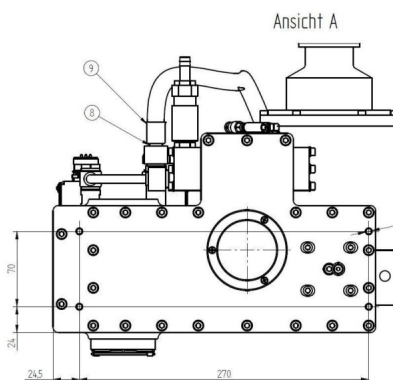
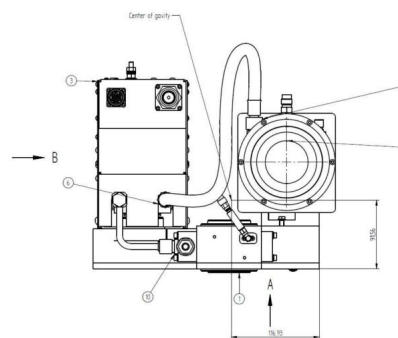
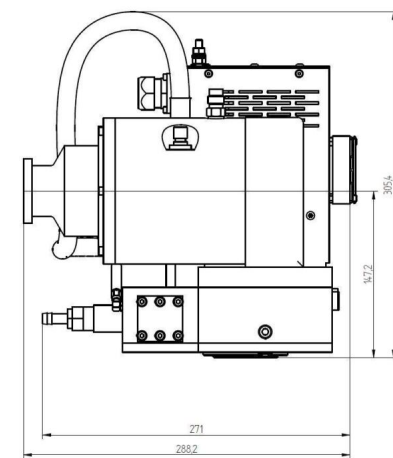


RADICAL PLASMA SOURCE (REMOTE PLASMA SOURCE) - MA3000C-403BB

Category: Plasma components



BILDERGALERIE



ADDITIONAL INFORMATION

| | |
|----------------------------------|--|
| Typ | Radical plasma source (Remote Plasma Source) |
| Process | Etching & Deposition |
| Output Connection Type | |
| Dielectric material | Sapphire |
| Mains voltage nominal [V] | 230 / 208 |
| Output Power CW [W] | 3000 |
| Frequency [MHz] | 2450 |